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is possible to reduce manufacturing cost of a frame of the system, and also to reduce a time to undertake the construction.

Please amend the paragraph beginning at line 11 of page 11, as follows:

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As shown in Fig. 1, a loader ~~opening~~^{opening}, i.e., the closing openings 11, and unloader opening, i.e., closing openings 12, are respectively provided at the front wall surface of the system body 1, wherein the closing openings 11, 12 have sectional areas through which carriers storing therein wafers W, W ..., described later, can be inserted in two stages, i.e., upper and lower stages. Both the closing openings 11, 12 have an automatic shutter mechanism formed of a see-through cover through which the inside thereof can be seen, and they can be slid vertically so as to form a sealed construction which is automatically opened or closed. As a result, it is possible to prevent particles and the like from entering from a clean room to the loading/unloading booth A to the minimum. Depicted by 13 is a HEPA filter through which clean air is introduced into the loading/unloading booth A. Depicted by 14 is a display serving also as a touch panel through which an operation system of a system program by way of recipes and parameters is set. There are provided an emergency stop button (red) 15 and a temporally stop button (green) 16 at the right side of the display 14, and hand ~~pendant~~^{pendant} connector 17 and potentiometer 18 to be connected on an operation board are provided at the right side of the temporally stop button 16. An alarm buzzer 20 is provided at the left side of the display 14 and ON/OFF switches 21 are provided under the alarm buzzer 20 for actuating or stopping various units. Closing doors 22, 23 each provided with a lock mechanism for locking an electric system of the units and a variety of electric components such as sequencers and the like are provided

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over the display 14 in parallel with each other. Maintenance openings 24, 25 for use in various driving mechanism of the loading/unloading booth A are provided under the front wall surface so as to be opened and closed.

Please amend the paragraph beginning at line 10 of page 13, as follows:

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An emergency stop button 45, a pause (temporally stop) button 46 and hand ~~penduct~~ pendant connector 47 are respectively provided on a rear side wall surface of the system body 1 as shown in Fig. 4, while an indicator showing an N₂ pressure or air pressure at a use point for operating the substrate cleaning chamber 10 and a panel 48 provided with a regulator and the like are disposed thereunder. Depicted by 49 and 50 are maintenance openings for the substrate cleaning chamber 10 of the processing booth C, wherein the openings 49, 50 has a double seal structure for effectively preventing the liquid of cleaning solution and the like to the outside of the system body 1. Depicted by 51, 52 are air discharge opening for discharging air inside the system body 1, and 53, 53 ... are connector pores for connecting to various pipes.

A new Substitute Specification is attached hereto which includes the above amendments.

No new matter has been added.